Docket No.: 55071-131

## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Xuelong SHI, et al.

Serial No.: 10/083,683

Filed: February 27, 2002

Customer Number: 20277

For:

HI, et al.

.: 10/083,683

Examiner: L.M.

METHOD OF IDENTIFYING AN EXTREME INTERACTION PITCH KENMETHODS OF DESIGNING MASK PATTERNS AND MANUFACTURING MASINDEVICE MANUFACTURING METHODS AND COMPUTER PROGRAMS

INFORMATION DISCLOSURE STATEMENT

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LINFORMATION DISCLOSURE STATEMENT METHODS OF DESIGNING MASK PATTERNS AND MANUFACTURING MASKS,

Mail Stop DD Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

## **CERTIFICATION PARAGRAPH**

The undersigned certifies that, to the best of his knowledge, each item of information contained in this Information Disclosure Statement was first cited in a communication from a

10/083,683

foreign patent office in a counterpart foreign application not more than three months prior to the

filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application

search report or office action and its relevance discussed therein. A copy of the foreign search

report or office action, together with an English language version thereof, is attached for the

Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Registration/No. 36,139

600 13<sup>th</sup> Street, N.W.

Washington, DC 20005-3096 (202) 756-8000 MEF:jgh

Facsimile: (202) 756-8087

Date: January 6, 2004

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INFORMATION DISCLOSURE  CITATION IN AN  APPLICATION  JAN 0 6 2004							ATTY. DOCKET NO. 55071-131 SERIAL NO. 10/083,683					i
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	XP00901538		Kim H-J Et Al: "FABRICATION OF DENSE CONTACT PARTTERNS USING HALFTONE PHASE-SHIFTING MASK WITH OFF-AXIS ILLUMINATION" Proceedings of the SPIE. SPIE, Bellingham, VA., US, vol. 2793, 18 June 1996, page 106-114, XPOO9015384 ISSN: 0277-786X									
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.